

Tyndall Equipment Catalogue

Technologies

- Characterisation
- Post-processing
- Processing

Substrates

- Glass Wafers (80)
- Silicon (CMOS Compatible) (137)
- Silicon (MEMS) (130)
- Silicon (Other) (121)
- III-V (125)
- Other Substrates (122)

Equipment

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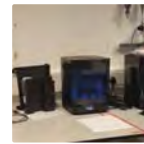
Characterisation (84)



Post-processing (22)



Processing (41)



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3D Printer - Formlabs (WSN)

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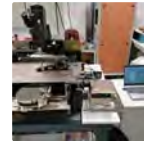
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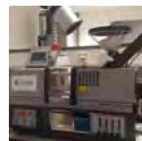
Applied Materials ALD reactor

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AST Rapid Thermal Anneal

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Babyplast Injection Moulding

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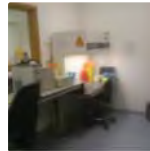
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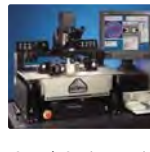
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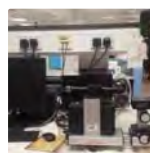
CHI 660C Potentiostat / Galvanostat

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Die Bonder

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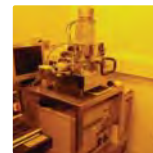
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EVG Single Wafer Cleaning System

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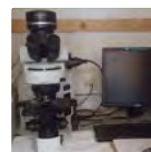
EVG120 Automated resist spin-coating and develop system

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FTIR

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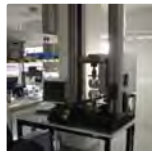
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Optical Spectrum Analyser (OSA)

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Oxford (III-V)

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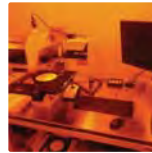
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SRS SR785 102.4kHz
Spectrum Analyzer

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Device (SQUID)

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System

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evaporator

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Electron-beam

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Substrates

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- [III-V](#) (3)
- [Other Substrates](#) (2)



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